INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

April 14, 2026

IGI Report Number	LG789641770
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	6.36 - 6.42 X 3.83 MM

GRADING RESULTS

Carat Weight	1.01 CARAT
Color Grade	D
Clarity Grade	VVS 2
Cut Grade	VERY GOOD

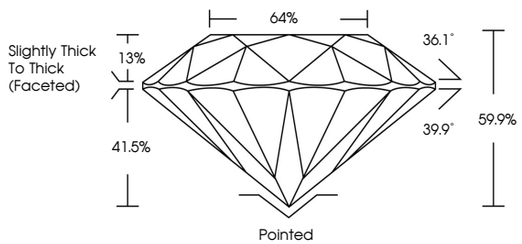
ADDITIONAL GRADING INFORMATION

Polish	VERY GOOD
Symmetry	VERY GOOD
Fluorescence	NONE
Inscription(s)	LG789641770

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG789641770
Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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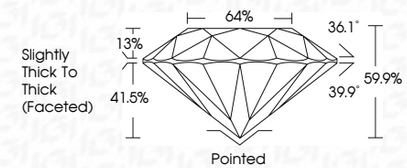

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IGI

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IGI Report No.LG789641770
ROUND BRILLIANT
6.36 - 6.42 X 3.83 MM
Carat Weight 1.01 CARAT
Color Grade D
Clarity Grade VVS 2
Cut Grade VERY GOOD
Depth 59.9%
Table 64%
Girdle Slightly Thick To Thick (Faceted)
Culet Pointed
Polish VERY GOOD
Symmetry VERY GOOD
Fluorescence NONE
Inscription(s) LG789641770
Comments:
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Type IIa